

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Young Ho BAE	Conf.:	3483
Appl No:	10/029,035	Art Unit:	1792
Filed:	December 28, 2001	Examiner:	R. N. KACKAR
For:	VACUUM DEPOSITION APPARATUS		

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated November 16, 2007, please amend this application as follows.

This paper includes:

Amendments to the Specification;

Amendments to the Drawings;

Amendments to the Claims; and

Remarks/Arguments.